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Technology Center 2600

THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:

SUMIKAWA, et al.

SMB.

PATENT

0033-0694P

Appl. No.:

09/782,180

Filed:

February 14, 2001

For:

SEMICONDUCTOR DEVICE AND METHOD OF

MANUFACTURING THE SAME

Group: 2814

Examiner: D. NGUYEN

METHOD OF

ON DISCLOSURE

. 2002 SUPPLEMENTAL TO THE INFORMATION DISCLOSURE

STATEMENT FILED MAY 22, 2002

Assistant Commissioner for Patents Washington, DC 20231

June 13, 2002

Sir:

Supplemental to the Information Disclosure Statement filed on May 22, 2002, attached are copies of partial English translations for DE19740055A1 and WO99/26287. These translations are provided for the Examiner's convenience and recently became available.

If the Examiner has any questions concerning the IDS, he/she is requested to contact the undersigned. If it determined that the IDS has been filed under the wrong rule, the PTO is requested to consider the IDS under the proper rule and charge the appropriate fee to Deposit Account No. 02-2448.

If necessary, the Commissioner is hereby authorized this, concurrent, and future replies, to charge payment credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. § 1.16 or under § 1.17; particularly, extension of time fees.

Respectfully submitted,

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0033-0694P

Enclosures: partial English translations